

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re PATENT Application of)
Masahiro ISHIDA)
Serial No. 10/032,563) Art Unit: 2812
Filed: January 2, 2002) Examiner:
For: METHOD OF MANUFACTURING)
NITRIDE SEMICONDUCTOR)
SUBSTRATE) Date: February 14, 2002


POWER TO INSPECT AND MAKE COPIES

Honorable Commissioner for Patents and Trademarks
Washington, D.C. 20231

Sir:

The undersigned attorney of record hereby authorizes Billie J. Huffman to inspect and/or make copies of the subject application including any and all documents associated therewith.

Respectfully submitted,


Eric J. Robinson
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